



# *Conductive Anodic Filament (CAF) Formation: A Potential Reliability Problem for Fine-Line Circuits*

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# *Outline*

- Introduction & Background
- Factors Affecting CAF Formation
- CAF Formation
  - » Catastrophic Field Failure of Military Hardware
  - » Laboratory Experiments
- Conclusion





# *Electronic Packaging Drivers*

- Reduced feature size on chips
- Increased I/O count per chip
- Increased clock speed
- Smaller leads and finer pitch
- Higher power dissipation
- Lighter weight
- Higher functionality





# *Progression of Electronic Circuitry*

## ● Increasing Power

| <b>Power: Single Chip Package (watts)</b> | <b>1995 - 1998</b> | <b>2001 - 2003</b> | <b>2004 - 2006</b> |
|---|--------------------|--------------------|--------------------|
| <b>Commodity</b>                          | <b>1</b>           | <b>1</b>           | <b>1</b>           |
| <b>Hand-Held</b>                          | <b>2</b>           | <b>2</b>           | <b>2</b>           |
| <b>Cost/Performance</b>                   | <b>16</b>          | <b>22</b>          | <b>28</b>          |
| <b>High-Performance</b>                   | <b>80</b>          | <b>120</b>         | <b>140</b>         |
| <b>Automotive</b>                         | <b>3</b>           | <b>3</b>           | <b>3</b>           |

## ● Increasing Chip I/O Density

| <b>Chip Pad Count</b>   | <b>1995 - 1998</b> | <b>2001 - 2003</b> | <b>2004 - 2006</b> |
|-------------------------|--------------------|--------------------|--------------------|
| <b>Commodity</b>        | <b>208</b>         | <b>324</b>         | <b>420</b>         |
| <b>Hand-Held</b>        | <b>300</b>         | <b>675</b>         | <b>880</b>         |
| <b>Cost/Performance</b> | <b>540</b>         | <b>1200</b>        | <b>1600</b>        |
| <b>High-Performance</b> | <b>900</b>         | <b>2000</b>        | <b>2600</b>        |
| <b>Automotive</b>       | <b>132</b>         | <b>300</b>         | <b>400</b>         |



# *Progression of Electronic Circuitry*

- Decreasing Conductor Width and Spacing

| Conductor Width & Spacing ( $\mu\text{m}$ ) | pre-1997 | 1997 - 1999 | 2000 - 2010 |
|---|----------|-------------|-------------|
| Hand Held                                   | 125-75   | 75-50       | 50-25       |
| Business/Industrial/Test                    | 150-100  | 100-75      | 100-50      |
| Automotive/Underhood                        | 200-125  | 150-100     | 125-75      |
| Military/Aero-Avionics                      | 125-75   | 75-50       | 50-20       |
| Computer Workstation/Server                 | 125-50   | 75-50       | 25-20       |

Values listed are upper and lower limits for conductor width and spacing in microns.

1 micron =  $1\mu\text{m}$  =  $10^{-6}$  m = 0.000039 in. = 0.039 mil  
typical human hair diameter =  $\sim 100\mu\text{m}$



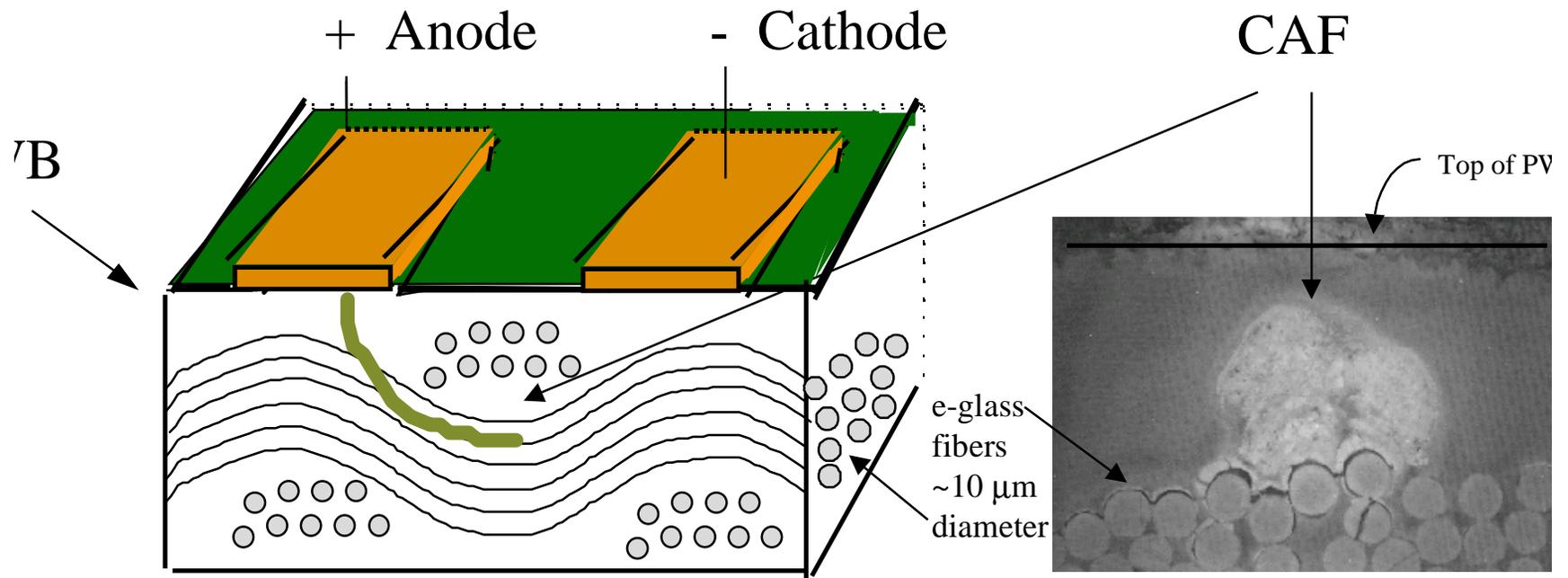
# *CAF Introduction*

- First identified by Bell Labs in 1976.
- Conductive, subsurface filament emanating from anode in high voltage (400V) PWBs exposed to high humidity (>80%).
- Can cause catastrophic failure if allowed to bridge between anode and cathode.



# What exactly is CAF?

- Conductive Anodic Filaments are copper corrosion by-products that emanate from the anode of a circuit and “grow” subsurface toward the cathode, frequently along separated fiber-epoxy interfaces.





# CAF Background

- Two step process.
- $t_{failure} = t_1 + t_2$ 
  - »  $t_1$  is related to the degradation of fiber/epoxy interface.
  - »  $t_2$  is related to the rate of the electrochemical corrosion reaction.
  - »  $t_1 \gg t_2$



## *t<sub>1</sub>, Degradation of Interface*

- Mechanical stress.
- Poor quality coupling agent.
  - » Promotes adhesion between fiber and epoxy during PWB/MLB “lay-up” operations.
- Thermal stress.
  - » Multiple soldering excursions cause thermal fatigue.
- Moisture attack.

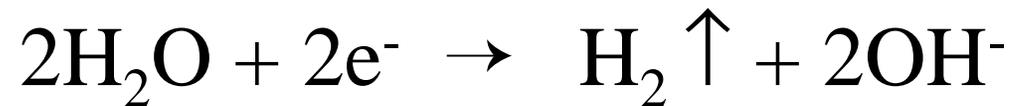


## *t<sub>2</sub>, Electrochemical Reaction*

Anode:



Cathode:



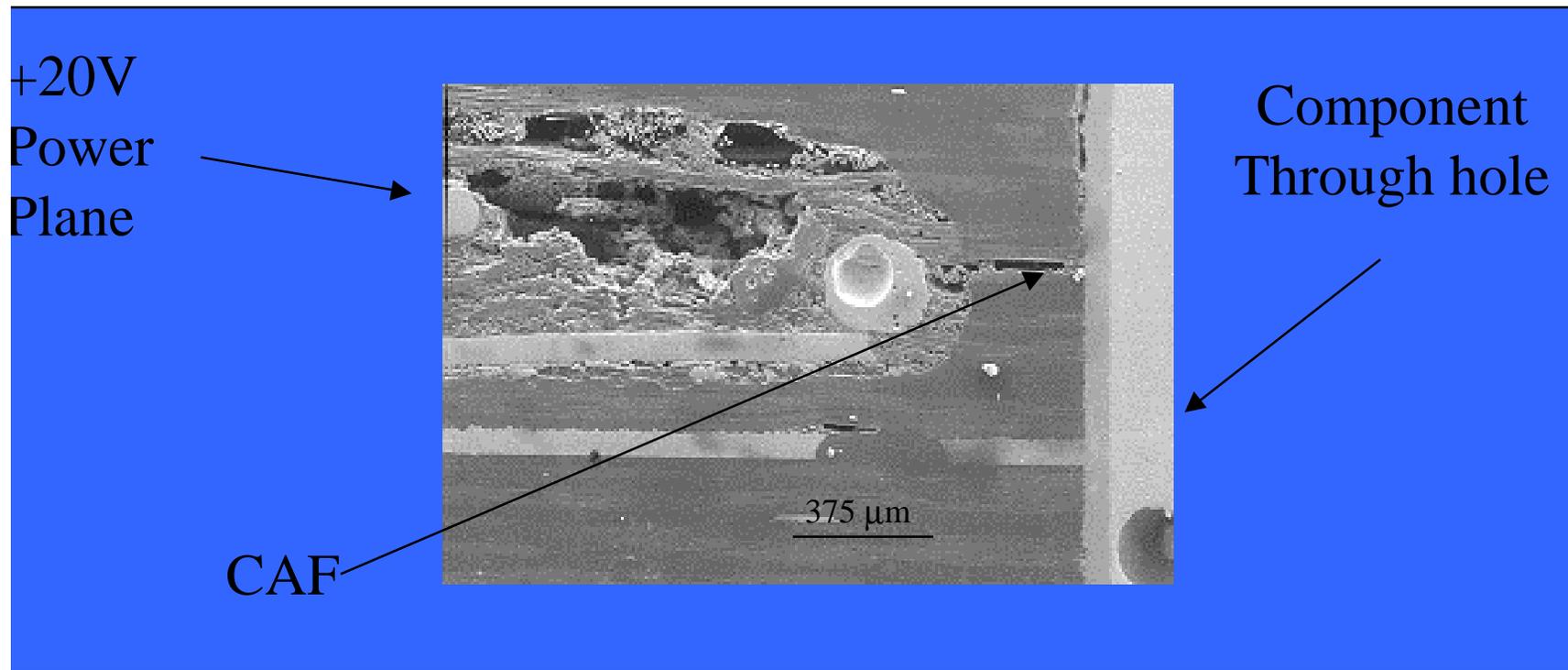


## *Factors Which Enhance CAF Formation*

- High humidity (~80% RH anytime during life of product).
- High voltage gradient between anode and cathode (~3-8 V/mil.).
- Certain soldering flux ingredients.
- Hole drilling.
- Multiple thermal cycles during processing.

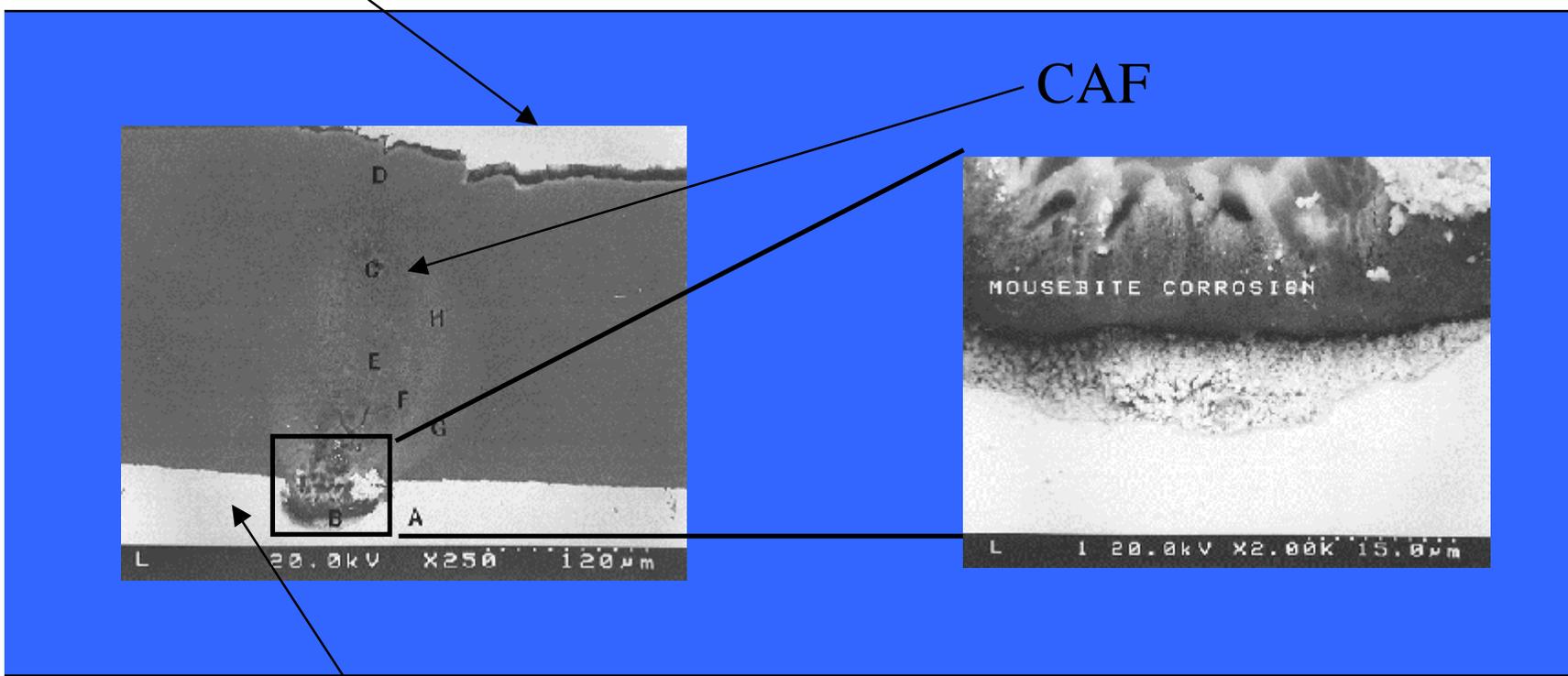
## *Catastrophic Field Failure of Military Hardware, Flux Enhanced Degradation*

- CAF, if allowed to bridge the gap between anode and cathode of the circuit, will create a “short” in the assembly.



# Catastrophic Field Failure of Military Hardware

Component Through Hole



+20 V Power Plane

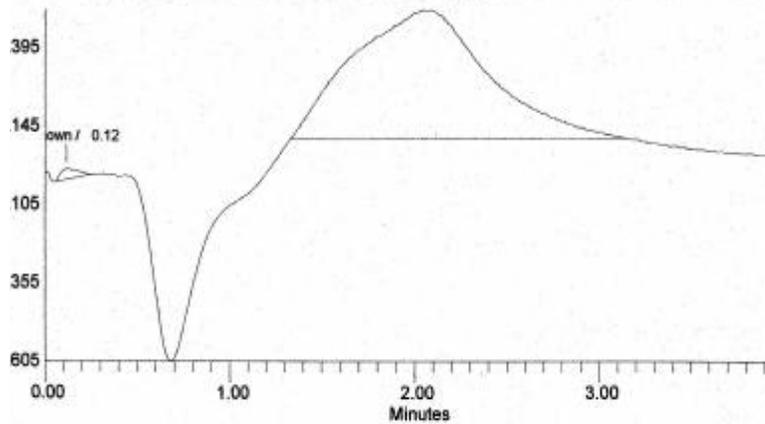


# Catastrophic Field Failure of Military Hardware

## Ion Chromatography Spectra

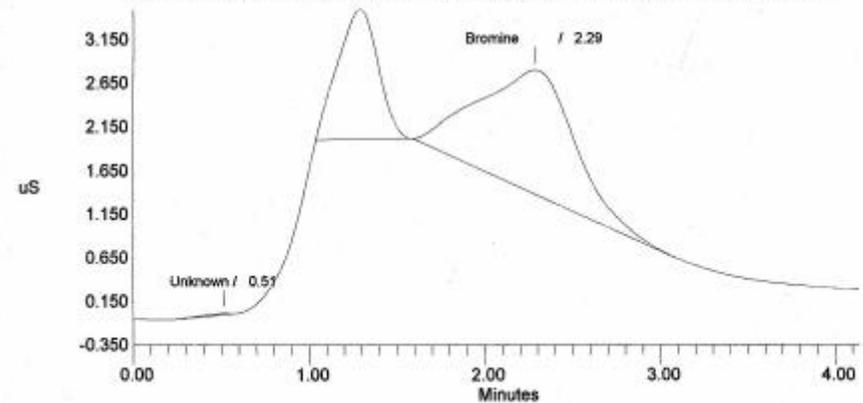
| Ret Time | Component Name | Concentration | Height | Area     | Bl. Code | %Delta | Pk. Num | Ret Time | Component Name | Concentration | Height  | Area     | Bl. Code |
|----------|----------------|---------------|--------|----------|----------|--------|---------|----------|----------------|---------------|---------|----------|----------|
| 0.12     |                | 0.000         | 34195  | 219651   | 1        |        | 1       | 0.51     |                | 0.000         | 16318   | 190484   | 1        |
| 2.05     |                | 0.000         | 410048 | 20870390 | 1        |        | 2       | 1.29     | Chloride       | 3.577         | 1490761 | 23940710 | 1        |
|          |                |               |        |          |          |        | 3       | 2.29     | Bromine        | 13.976        | 1421769 | 53266765 | 1        |

File: C:\DX\DATA\brian\bas9-451.D03 Sample:



Failed Hardware

File: C:\DX\DATA\brian\bas9-491.D02 Sample: BROMIDE PROBLEM



Soldering Flux



# Laboratory Experiments

|   | Flux 1  | Flux 2a.  | Flux 2b.  | Flux 2c.  |
|---|---|---|---|---|
| <b>pH</b>   | 2.75  | 3.2   | 3.2   | 3.2   |
| <b>Ingredients and Percentages as Listed in MSDS or in Product Literature</b> | Isopropyl Alcohol (75 - 90%)                      | Isopropyl Alcohol (75 - 85%)                      | Isopropyl Alcohol (75 - 85%)                      | Isopropyl Alcohol (75 - 85%)                      |
|   | HBr (<5%)   |   | Amine HBr   | Amine HCl   |
|   | Polyglycol  | Triisopropanolamine                               | Triisopropanolamine                               | Triisopropanolamine                               |
|   |   | Polyol  | Polyol  | Polyol  |
|   |   |   |   |   |
| <b>Color</b>  | clear to pale yellow                              |
| <b>Flash Point</b>  | 60°F  | 59°F  | 59°F  | 59°F  |
| <b>Specific Gravity</b>   | 0.87  | 0.83  | 0.83  | 0.83  |
| <b>Use</b>  | foam, wave, or spray flux for SMT or Through Hole | foam, wave, or spray flux for SMT or Through Hole | foam, wave, or spray flux for SMT or Through Hole | foam, wave, or spray flux for SMT or Through Hole |



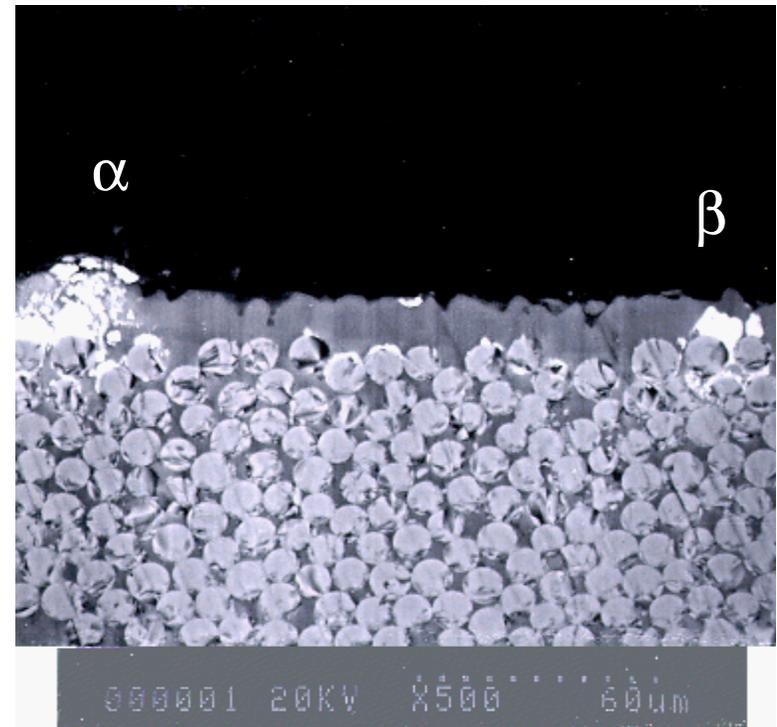
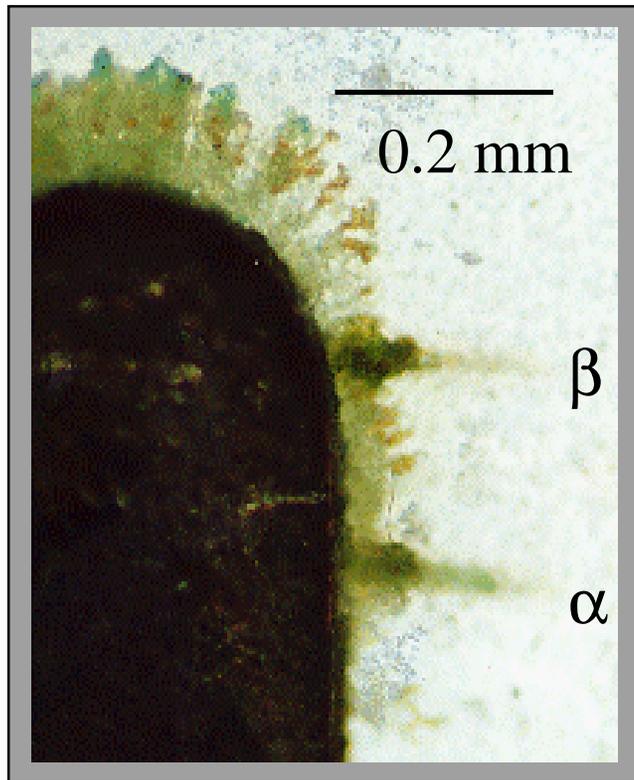
# Laboratory Experiments

|  | Flux 3              | Flux 4                             | Flux 5                  | HASL 1                    |
|--|---------------------|------------------------------------|-------------------------|---------------------------|
| <b>pH</b>  | 6.8                 | 2                                  | 2                       | <3.0                      |
| <b>Ingredients and Percentage as Listed in MSDS or in Product Literature</b> | 2-Propanol (64%)    | Ethoxylated Polyoxypropylene (35%) | Isopropyl Alcohol (70%) |                           |
|  | Chloride (2%)       | HBr (15%)                          |                         | HBr (10%)                 |
|  | Surfactants         | Polyalkylene Glycol (35%)          |                         | Nonionic Surfactant (75%) |
|  | Glycerol (11%)      | Polyglycol (15%)                   |                         |                           |
|  | Organic Acids       |                                    |                         |                           |
| <b>Color</b>   | pale amber to amber | clear to light yellow              | clear to pale yellow    | clear to dark amber       |
| <b>Flash Point</b>   | 60°F                | 525°F                              | 60°F                    | 600°F                     |
| <b>Specific Gravity</b>  | 0.9                 | 1.08                               | 0.92                    | 1.09                      |
| <b>Use</b>   | wave flux           | HASL / SMT                         | IR flux                 | vertical HASL             |

Flux used in field failure. \_\_\_\_\_ ↑

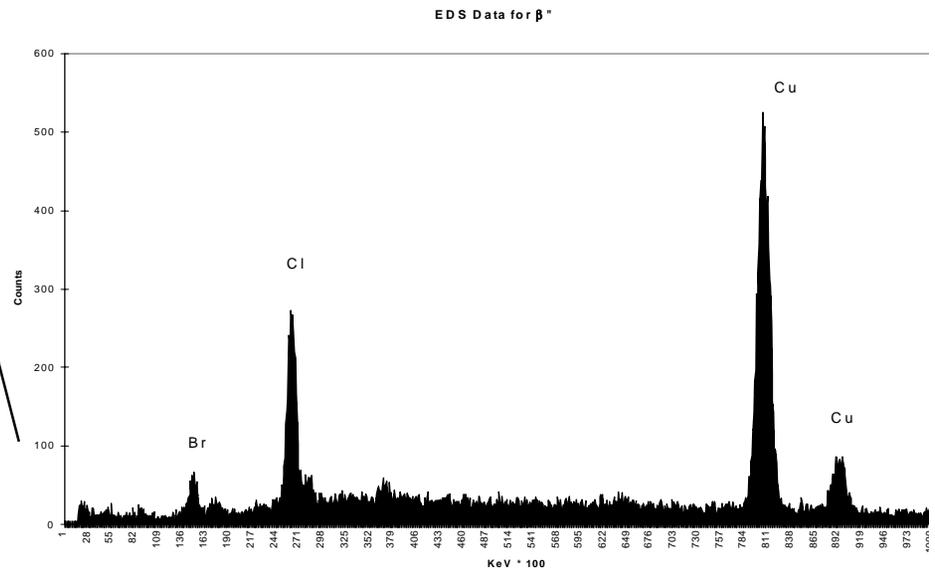
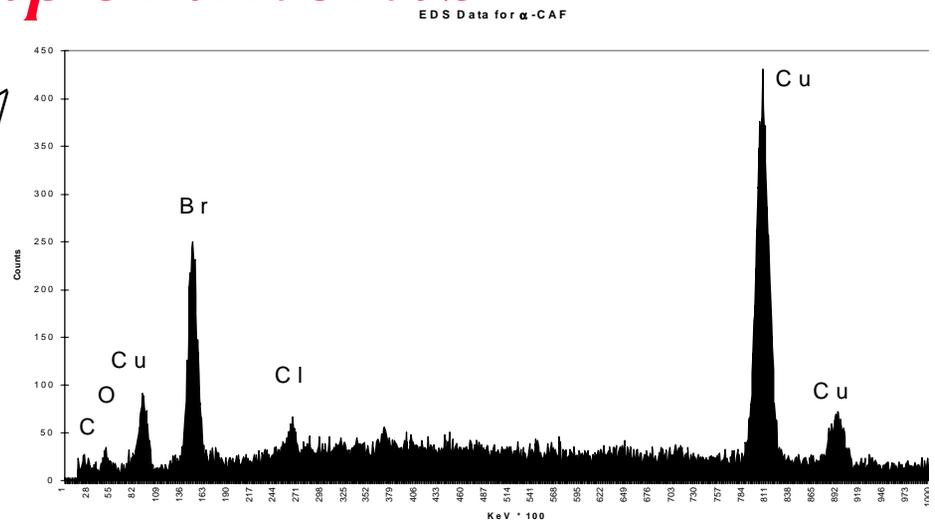
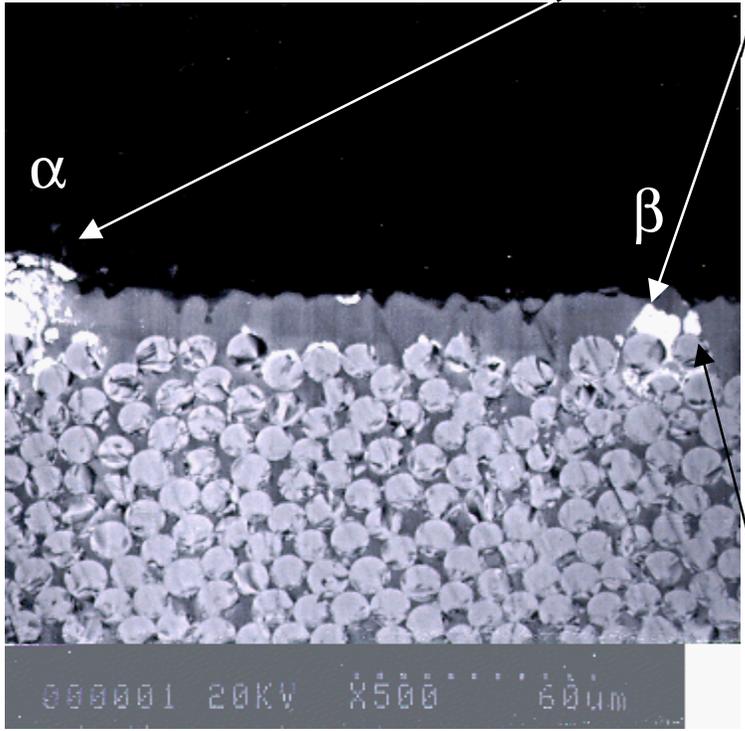
# *Laboratory Experiments*

CAF formed with *same* flux (Flux 4)  
that caused military field failure.





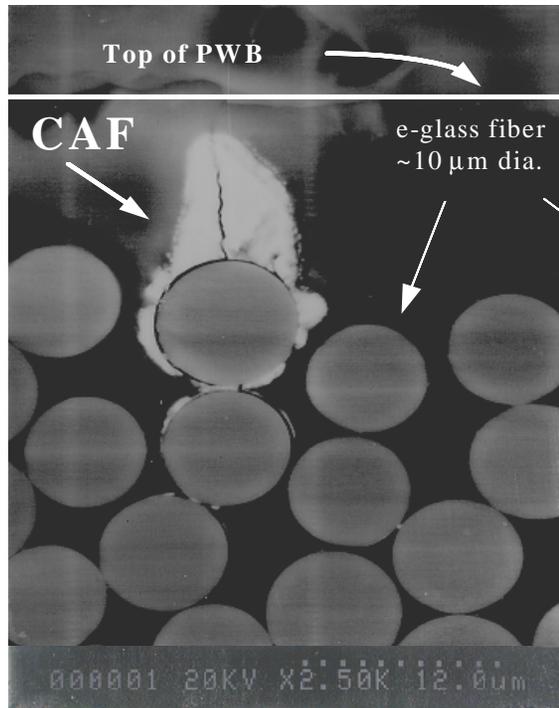
# Laboratory Experiments



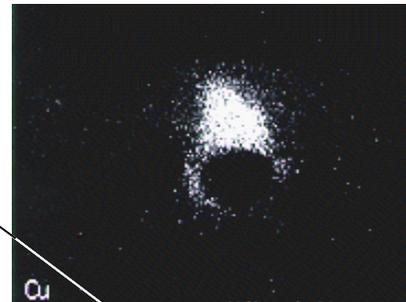
# *Laboratory Experiments*

## Wave Soldered FR-4 PWB Treated with Flux 1

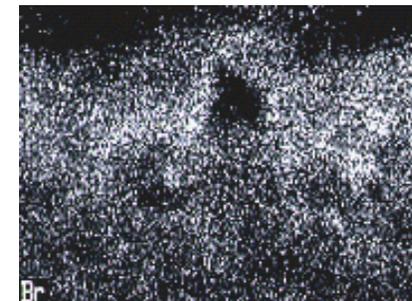
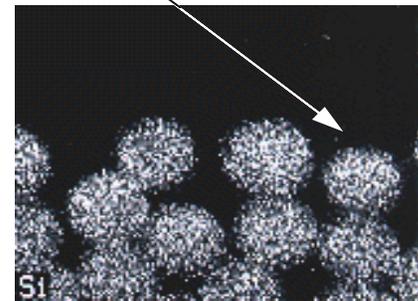
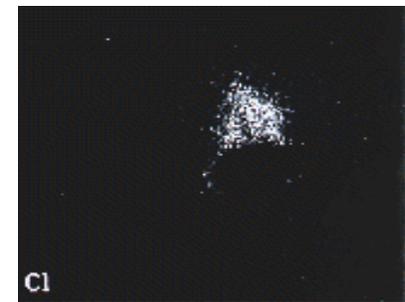
**BSEM Image @ 20kV**



**Cu x-rays**



**Cl x-rays**



**Si x-rays**

**Br x-rays**



# *Laboratory Experiments*

- Flux Chemistry Dependence
  - » CAF is frequently copper - chloride containing, but copper - bromide containing CAF has also been observed.
  - » All polyglycol containing fluxes (1,3,4 & 5) exhibited CAF.
  - » HBr and HCl in flux formulations were only deleterious when coupled with a polyglycol.



# *Conclusions*

- High density circuits have voltage gradients that make CAF formation a possibility.
- Catastrophic field failures can be linked to the flux and HASL used in manufacture.
- Tests on 5 flux chemistries reveal CAF when certain polyglycols were present.
- Future work is focusing on identifying the “bad” polyglycols.





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